1/6

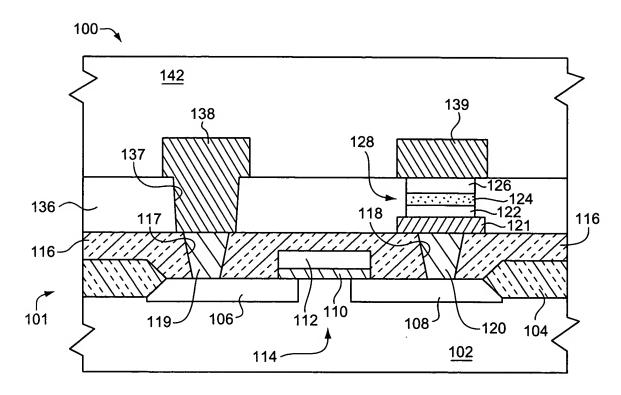


FIG. 1

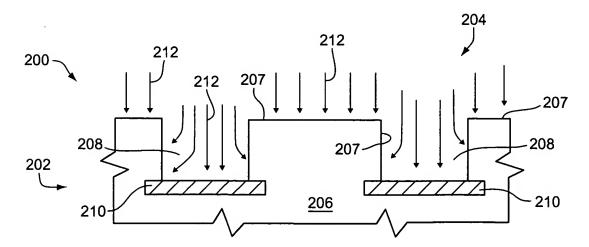


FIG. 2

2/6

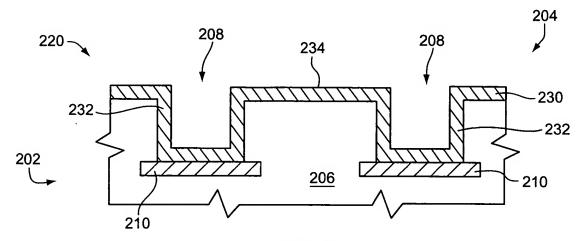


FIG. 3

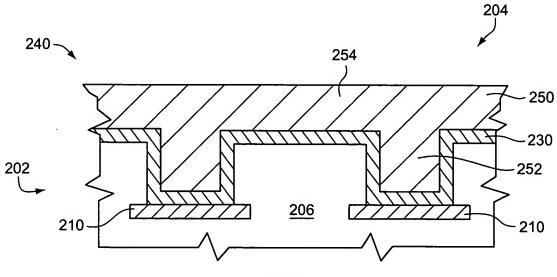


FIG. 4

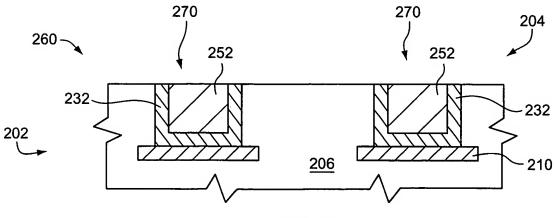


FIG. 5

Title: "Surface Treatment Using Iodine Plasma To Improve Metal Deposition"
Inventors: Dalton, et al. Application No.: Filed Herewith Docket No.: 101.114
Attorney: Thomas Swenson 303-440-7800

3/6

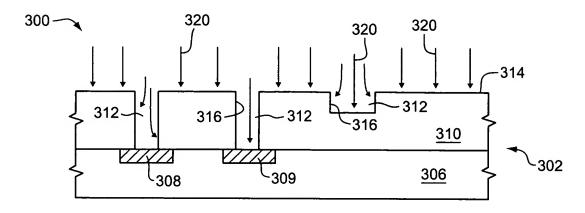


FIG. 6

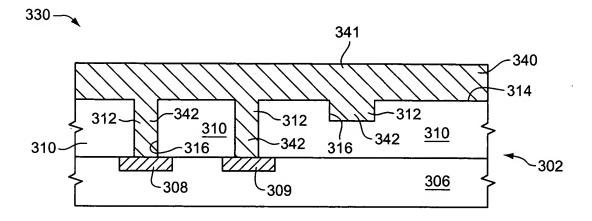


FIG. 7

330

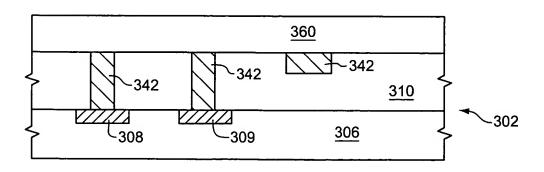


FIG. 8

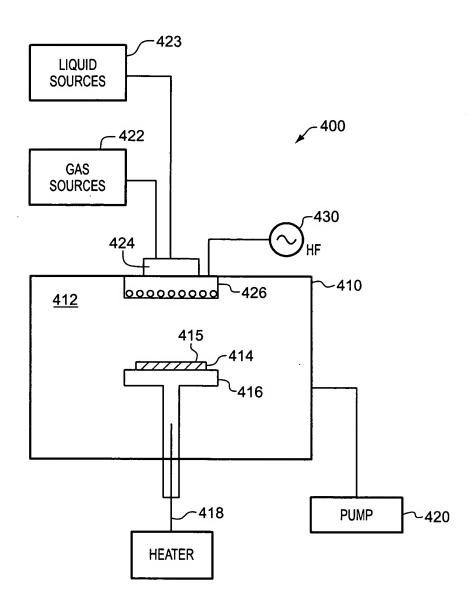
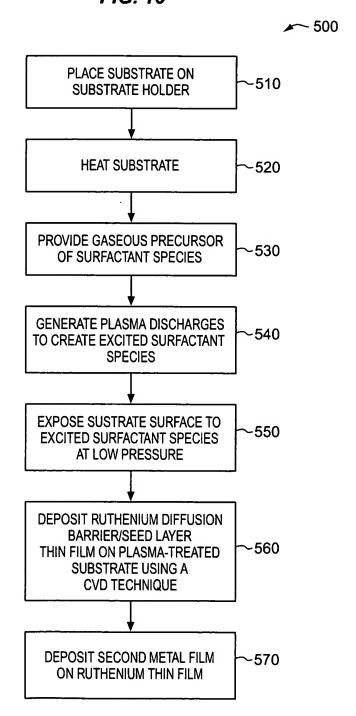


FIG. 9

5/6

FIG. 10





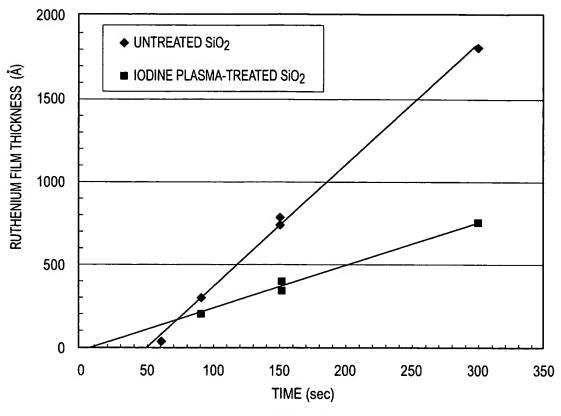


FIG. 11

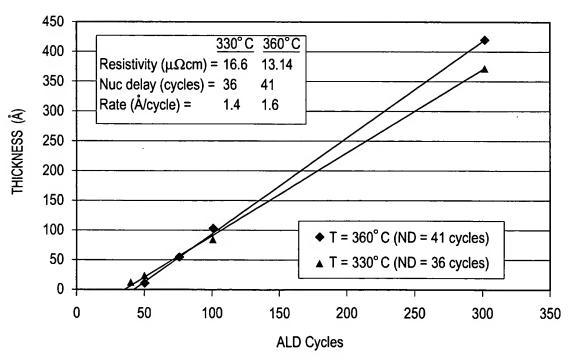


FIG. 12